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PATENT NUMBER and ISSUE DATE

U.S. UTILITY Patent Application

	APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER				
ı	10088306	03/18/2002	034	259	3749	O'Malley, Fathing				
	**APPLICANTS: Ohno Hiromoto; Ohi Toshio; Yoshida Shuji; Ohhira Manabu; Tanaka Koutarou;									
	**CONTINUING DATA VERIFIED: THIS APPLICATION IS A 371 OF PCT/JP01/06164 07/17/2001 WHICH CLAIMS BENEFIT OF 60/230,811 09/07/2000 * AND CLAIMS BENEFIT CF 60/261,265 01/16/2001 * (*)Data provided by applicant is not consistent with PTO records.									
** FOREIGN APPLICATIONS VERIFIED: JAPAN 2000-217610 07/18/2000 JAPAN 2000-397269 12/27/2000 JAPAN 2001-189388 06/22/2001										
	PG-PUB DO N	OT PUBLISH 🗖		RESCIN	_D \square					
1	oreign priority claimed □ yes □ 5 USC 119 canditions met □ yes □ eriaed and Acknowledged Examiners's initials				ATTORNEY DOCKET NO Q60716					
Ī	TITLE: Cleaning gas for semiconductor production equipment U.S.DEPT. OF COMM. (PAT & TM-PTO-4356 (Rev. 12-									

NOTICE OF ALL	OWANCE MAILED		CLAIMS ALLOWED						
		Assistant Examiner	Total Claims		Print Claim for O.G				
ISS	UE FEE		DRAWING						
Amount Due	Date Paid	•	Sheets Drwg. Figs.Dr		wg. Print Fig.				
	<u> </u>	Primary Examiner		<u> </u>					
TER	RMINAL	PREPARED FOR ISSUE	Application Examiner						
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